



Organic Semiconductors and Devices, 2nd Edition

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Message from the Guest Editor

Dear Colleagues,

Organic semiconductors are desirable, lightweight, and flexible materials for electronic applications. Significant merits of organic semiconductors include their chemical diversity, low-cost process fabrication, and compatibility with various substrates, including plastics, fiber substrates, and stretchable systems, which distinguish organic semiconductor-based devices from conventional devices.

This Special Issue calls for research papers, reviews, and short communications related to state-of-the-art developments contributing to electronic devices based on organic semiconductors, including small molecules, polymers, and organic–inorganic hybrid materials.

Dr. Hocheon Yoo
Guest Editor





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Message from the Editor-in-Chief

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